

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	148	((Michael near3 Landis)((Steven near3 Fink)).in.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/02/03 15:49
L2	33	1 and (central center\$3 ring) and plasma and chamber	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/02/03 16:30
L3	1	(US-20040129226-\$).did	US-PGPUB	OR	ON	2005/02/03 16:26
L4	55975	(central focus\$3 center\$3 ring) and plasma and chamber	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/02/03 16:31
L5	15037	4 and ((central focus\$3 center\$3 ring) same substrate)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/02/03 16:31
L6	516	4 and (((central focus\$3 center\$3) near3 ring) same substrate)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/02/03 16:34
L7	314	6 and (mark\$4 indicat\$3 wear\$3)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/02/03 16:35
L8	130	6 and ((mark\$4 indicat\$3 wear\$3) same (ring plate disk))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/02/03 17:06
L9	582	((((annular\$3 focus\$3 center\$3 central\$3) near5 ring) same ((surround\$3 around rotat\$4) near6 (wafer substrate\$1 electrode\$1)))) and plasma and chamber	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/02/03 17:19
L10	425	9 and ((mark\$4 indicat\$3 wear\$3 replac\$4 remov\$5) same (ring plate disk wafer))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/02/03 17:07
L11	363	10 and ((replac\$4 remov\$5) same (ring plate disk wafer substrate))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/02/03 17:08
L12	2	("5789876").PN.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/02/03 17:19